

As of May 16

< Cancellation >

Day-3, May 18, Thursday

Th1-8, JS-02 SP J1-2 (T. Ota) Room 1

#Th2-16, LPM-16 (S. Lazare) Room 2

#Th3-7, LPM-19 (S. Lazare) Room 3

Th4-5, HPL-11 (P. Aubry) Room 4

Th4-7, HPL-11 (X. Huang) Room 4

Th4-9, HPL-12 (P. Aubry) Room 4

Day-4, May 19, Friday

Fr4-8, HPL-17 (A. Jansson) Room 4

As of May 18

Presenter Changed

Day - 3, May 18, Thursday

Th3 - 13, LPM - 21 Room 3

K. Kawaguchi, AIST, Japan

→H. Niino, AIST, Japan

Day - 4, May 19, Friday

Invited Talk, Fr2 - 1, LPM - 23 Room 2

A. Boyle, Xsil Ltd., Ireland

→Y. F. Lu, Univ. of Nebraska, USA

“Microprocessing for Semiconductor Industry”

As of May 18

Session Chair Changed

Day - 3, May 18, Thursday

LPM - 20 Room 3

S. Lazare, Univ. Bordeaux 1, France

→S. Juodkazis, Hokkaido Univ., Japan

Day - 4, May 19, Friday

LPM - 24 Room 2

A. Boyle, Xsil Ltd., Ireland

→T. Hoult, SPI Lasers LLC, UK